

DOCKET NO: 265523US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HARUHIKO FURUYA, ET AL. : EXAMINER: MALDONADO, J.
SERIAL NO: 10/523,974 :
FILED: FEBRUARY 8, 2005 : GROUP ART UNIT: 2823
FOR: SEMICONDUCTOR PROCESSING :
METHOD AND APPARATUS FOR
PROCESSING TARGET SUBSTRATE

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated July 2, 2007, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 8 of this paper.